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Terahertz adaptive optics with a deformable mirror

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We report on the wavefront correction of a terahertz beam using adaptive optics which requires a wavefront sensor able to sense the optical aberrations and a wavefront corrector. The wavefront sensor relies on a direct 2D electro-optic imaging system composed of a ZnTe crystal and a CMOS camera. By measuring the phase variation of the terahertz electric field in the crystal, we were able to minimize the geometrical aberrations of the beam thanks to the action of a deformable mirror. This phase control will open the route to terahertz adaptive optics in order to optimize the THz beam quality for both practical and fundamental applications. © 2019 Optical Society of America

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Wavefront control of optical beams is essential to lessen the geometrical aberrations and optimize the performances of an optical system. This aspect is essential in astronomy where the turbulence of the atmosphere strongly affects the electromagnetic waves detected by the telescopes in visible and near-infrared spectral regions. The dynamic evolution of the atmosphere induces strong changes in the air optical index which strongly corrugates the image quality of astronomical imagers [1]. This problem has been efficiently solved with the emergence of adaptive optics (AO) which combines the use of a wavefront analyzer together with a deformable mirror (DM) which can correct in realtime the turbulence of the atmosphere. At present, for visible and near-infrared wavelengths, commercially available AO systems can control the geometrical aberrations of an optical system, providing a mature technology for many applications including not only astronomy, but also ophthalmology and microscopy [2]. In practice, wavefront meaurement can be accomplished with a Shack-Hartmann sensor that can locally measure the wavefront slopes of an incoming optical beam [3]. A computer allows to estimate the wavefront shape from the slope measurements and deduce the shape to be compensated by the DM. Various DM technological concepts have been developed to achieve the wavefront control and provide the final correction of the optical aberrations. These specifically designed mirrors are characterized by the number of actuators used to deform the mirror surface, the actuator pitch and stroke, and its response time to the external control signal. Typically, for the first systems dedicated to astronomy, 180 actuators in total where requested to provide an efficient correction in the infrared. In the last systems installed at VLT [4], up to 1300 actuators in total are required for a high level correction in the visible spectrum.

In the terahertz (THz) spectral domain, it is still challenging to correct the spatial profile and wavefront of a beam. The wavefront measurement in itself is not straightforward, due to the lack of effective THz 2D detectors. However, this measurement is essential to optimize the spatial resolution or illumination uniformity of THz imaging systems, developed for a large variety of applications such as security and defense, non-destructive testing of industrial materials, etc. [5]. Wavefront measurement of THz pulses is also mandatory for the control of far-field intensity distribution of time-domain spectrometers or to increase the peak power of intense terahertz sources and optimize the beam focalization of scanning THz time-domain imaging systems [6].

The measurement of THz wavefronts for both continuous wave and pulsed sources has been tentatively studied in the past few years. In 2008, Bitzer et al. determined the beam profiles of THz pulses after passing through a hyper-hemispherical silicon lens [7]. In 2012 and 2013, Cui et al. proposed the first THz wavefront measurement associated with a Hartmann sensor and indirect scanning method, detecting the radiation with a pyroelectric sensor [8, 9]. Richter et al. presented a similar arrangement with a 2D detection consisting in a microbolometer camera [10, 11]. Another aperture scanning device was proposed to characterize the THz beam propagation in a time-domain spectrometer [12]. In 2016, we proposed the wavefront characterization of THz pulses using a Hartmann sensor associated with a 2D electro-optic (EO) imaging system [13]. Nevertheless, our indirect method used a metallic mask which limited the beam transmission and required an initial calibration or reference measurement. More recently, we reported on the development of a wavefront sensor for THz pulses using a direct 2D EO imaging system composed of a ZnTe crystal and a CMOS camera [14]. We were able to reconstruct the THz wavefront in order to determine the geometrical aberrations of the optical system without any prior reference measurement.

In this letter, we propose to combine this direct wavefront measurement of THz pulses with the simultaneous utilization of a DM in order to minimize the geometrical aberrations of the THz beam. The device is adapted for THz sources delivering short and intense THz pulses such as air plasma THz generation and optical rectification in nonlinear crystals. After verifying that the system is able to properly measure and control the THz wavefront modified by the action of the DM, we will finally Letter



Fig. 1. Experimental setup. DM: ALPAO deformable mirror, C: chopper, M: metallic planar mirror, L: plano-convex THz lens, f' = 50 mm focal length.

Broadband THz pulses (0.1-3 THz) were generated by optical rectification of amplified femtosecond laser pulses (800 nm, 1 mJ, 150 fs, 1 kHz repetition rate) in a 1 mm-thick ZnTe crystal with a clear aperture of 25 mm. In order to measure and correct the wavefront of the THz electric field, the beam is sent on the DM at $\alpha = 16^{\circ}$ incidence angle with respect to the normal of the mirror (Fig. 1). This latter is commercialized by ALPAO, specialized in AO components and systems. The DM 97-15 model has the following characteristics: aluminium membrane, 97 magnetic actuators, 13.5 mm pupil diameter, 1.5 mm pitch and 11 actuators across a diameter. The tip/tilt stroke is >60 μ m PV and the defocus/astigmatism stroke is >40 µm PV. The local deformation between two adjacent actuators is typically >5 µm and the setting time is as fast as 800 µs. It is important to note that this mirror is not perfectly adapted to THz frequencies since the 5 µm total course of each actuator is 60 times smaller than the wavelength at 1 THz. Therefore, we have to bear in mind that this mirror will not be able to induce large optical phase shifts and correct large geometrical aberrations in the THz spectral range.

After the reflection on the DM, the THz beam is sent into a second 1 mm-thick ZnTe crystal for the detection of the THz electric field. Additionaly, we used two plano-convex THz lenses with f' = 50 mm focal lengths to conjugate the deformable mirror plane with the ZnTe crystal one in a classical 4f' configuration with a 1:1 magnification. In this condition, the phase shift induced by the deformable mirror on the THz wave is directly transferred to the crystal plane where the wavefront is measured. Thanks to a collinear EO detection with a time-delayed femtosecond laser probe pulse reflected by the front (left side in Fig. 1) face of the crystal, we are able to measure the THz electric field by capturing the laser probe intensity with a CMOS camera [14]. Thanks to the objective lens located in front of the camera, the crystal plane is conjugated with the CMOS chip. Consequently, the DM is actually conjugated with the camera. For a given time delay *t* between the THz and the probe pulses, the system is able to provide a 2D (x-horizontal and y-vertical directions) image at 800 nm corresponding to the distribution of the THz electric field $E_{THz}(x, y, t)$ at the crystal position. This image can be obtained with a 500 Hz acquisition rate thanks to the synchronization with the laser repetition rate and a dynamic subtraction method [15]. The experimental procedure to measure the THz wavefront has been detailed in [14]. Shortly, for every pixels of the camera, i.e. for every *x* and *y* positions in the ZnTe crystal plane, it is

possible to plot the corresponding temporal waveform $E_{THz}(t)$. Then, through a Fourier transformation of the temporal data, it is possible to calculate the amplitude and the phase of the complex electric field $E_{THz}(\Omega)$, where Ω is the THz frequency. In our experiment, the THz spectrum extends from 0 to 3 THz [14]. It is next straightforward to plot the amplitude and the relative phase of $E_{THz}(x, y, \Omega)$ and obtain the final wavefront from the phase map, characterized by the surface of equiphase of the electromagnetic field.



Fig. 2. Analysis of the reference beam at 0.75 THz. Amplitude (a) and wavefront (b) in the ZnTe crystal plane. (c) Amplitude of the Zernike coefficients. The horizontal red lines indicate the noise level.

To illustrate this measurement procedure, the shape of the DM is first simply set as a planar mirror. This situation will provide the measurements of both the amplitude and phase of the so-called "reference" THz wave for any frequencies within the 0-3 THz spectral range. Note that we rely here on the ability of our sensor to characterize broadband THz pulses. For instance, Fig. 2(a) represents the amplitude distribution of this reference THz wave at $\Omega = 0.75$ THz, at the crystal position. There, the beam diameter is 13.5 mm, limited by the aperture of the DM which represents also the entrance pupil of the optical system. As shown in the figure, this entrance pupil is correctly imaged by the CMOS camera thanks to the 4f' optical configuration. The spatial inhomogeneity of the THz amplitude is due to the incoming pump laser beam and the optical rectification process in the first ZnTe crystal. We believe that the correction of this inhomogeneity could be addressed in further works by controlling the wavefront of the THz wave. To this aim, it would be necessary to modify the optical arrangement so that the phase shift induced by the DM would also change the amplitude of the THz wave in the crystal. Fig. 2(b) shows the THz wavefront at $\Omega=0.75$ THz, at the crystal position. We note that it is not planar with both horizontal and vertical geometrical aberrations, in the order of tens of µm PV, from one side to the opposite side of the beam.

To quantify these aberrations, the standard method consists in developing the wavefront surface W(x, y) onto a linear combination of the Zernike polynomial modes [16], W(x, y) = $\sum_i a_i Z_i(x, y)$, where a_i represents the amplitudes of the polynomial Z_i , each polynomial corresponding to one specific optical aberration. Fig. 2(c) represents the amplitudes in μm of the 20 first Zernike polynomial modes, after decomposition of the wavefront presented in Fig. 2(b). Except the vertical and horizontal tilts (tip/tilt) which are not intrinsic to the THz wave but mainly related with the overlapping with the laser probe beam, the main aberrations are negative defocus (-16 µm), vertical astigmatism (-8 µm), horizontal coma (4 µm) and vertical secondary astigmatism (5 μ m). The other aberrations are smaller or close to the measurement limit accuracy ($\pm 2.5 \mu m$), indicated by the horizontal red lines in the figure [14]. This noise level is as small as $\lambda/160$ at 0.75 THz, emphasizing the high sensitivity of our wavefront sensor. From this first experiment, we can conclude that the reference THz wavefront is not perfectly planar with residual geometrical aberrations in the order of $\lambda/40$ in terms of Zernike amplitudes.

Before correcting the reference THz wavefront, we have to verify that our wavefront sensor is able to measure the modifications induced by the DM on the optical system. For that, with the DM controller, we generated the wavefronts of 9 specific Zernike polynomials modes, such as horizontal tilt, defocus, vertical astigmatism, vertical trefoil, horizontal coma, oblique quadrafoil, oblique secondary astigmatism, spherical aberration and vertical secondary coma. For each mode, we set the amplitude of the Zernike coefficient a_i as indicated in the second column in Table 1. Fig. 3(a)-(i) shows the wavefronts measured at 0.75 THz corresponding to these 9 modes. These images have been obtained by subtracting the reference wavefront (Fig. 2(b)) in order to remove the intrinsic aberrations induced by the reference THz beam itself. Clearly, all Zernike modes are properly transferred to the THz wave and measured by the THz wavefront sensor. The third column in Table 1 gives the amplitudes of each mode, measured after developing each THz wavefront with respect to its corresponding mode. Considering that the measurement uncertainty is $\pm 2.5 \,\mu$ m), the experimental amplitudes are in good agreement with the amplitudes set by the DM controller, indicating the ability of our optical system to properly control an incoming THz wavefront.

Table 1. Amplitude of the Zernike modes measured by theTHz sensor.

Mode name	Set (μ m) Measured (μ m) Rel. error (%)		
Hor. tilt	25	24.8	0.8
Defocus	-20	-18.3	8.5
Vert. astigm.	-15	13.7	8.7
Vert. trefoil	7.5	7.1	5.3
Hor. coma	7.5	5.9	21.3
Obl. quadrafoil	-7.5	-7.5	0.0
Obl. second. astigm.	-7.5	-6.1	18.7
Sph. aberration	-7.5	-6.0	20.0
Vert. second. coma	7.5	5.2	30.7

The final experiment consists in correcting the reference THz wavefront with the DM in order to remove the aberrations and optimize the optical configuration for further applications such



Fig. 3. Wavefronts at 0.75 THz for different deformations of the DM. (a) Horizontal tilt. (b) Defocus. (c) Vertical astigmatism. (d) Vertical trefoil. (e) Horizontal coma. (f) Oblique quadrafoil. (g) Oblique secondary astigmatism. (h) Spherical aberration. (i) Vertical secondary coma.

as spectroscopy or imaging. First, as already shown in Fig. 2(b) and (c), we measure and develop the reference THz wavefront onto the first 20 Zernike polynomial modes Z_i . We thus obtain a set of 20 Zernike polynomial amplitudes a_i . Then, we program the DM controller so that the shape of the DM corresponds to $-2\cos\alpha \times \sum_i a_i Z_i(x, y)$, where $\alpha = 16^\circ$ is the incidence angle of the THz beam onto the DM. With this simple procedure, the specific shape of the DM will exactly compensate the THz wavefront after the reflection so that the geometrical aberrations will be remove in the ZnTe crystal since this position is conjugated with the DM thanks to the 4f' optical configuration of the experiment. Fig. 4 shows the result of this correction, at 0.75 THz, with the reference (a) and corrected (b) wavefronts, the reference (c) and the corrected (d) Zernike decompositions. Even if remaining aberrations are still observed, the amplitudes are all smaller than 5 µm and close to the noise level of the wavefront sensor. We believe that the remaining aberrations are due to the limited courses of the DM actuators. Indeed, as explained before, this DM is adapted to visible and infrared light with a local deformation between two adjacent actuators of only 5 µm, which limits the maximum deformation of the whole mirror. For the correction presented in Fig. 2(b) and (c), the reference deformation in the center was out of range for a few actuators in this region, demonstrating that the DM is not perfectly adapted to our system. Nevertheless, this result demonstrates the ability of a DM to strongly attenuate the geometrical aberrations of a THz wave.

To evaluate the optimization of the THz wavefront, we calculated the Strehl ratio defined as the ratio of the on-axis intensities, in the presence and in the absence of aberrations. This number gives a measure of the quality of optical image formation [17]. It takes a value between 0 and 1, the latter corresponding to a perfectly unaberrated optical system. More precisely, the Strehl ratio can be expressed as $S = \exp[-(2\pi\sigma)^2]$, where σ is the RMS wavefront error in units of wavelength, directly related to the wavefront W(x, y), by $\sigma^2 = \langle W(x, y)^2 \rangle - \langle W(x, y) \rangle^2$, where $\langle . \rangle$



Fig. 4. Correction of the reference THz beam at 0.75 THz. (a) Reference wavefront. (b) Corrected wavefront. (c) Amplitude of the Zernike coefficients for (a). (d) Amplitude of the Zernike coefficients for (b). The horizontal red lines indicate the noise level.

is a spatial averaging. At 0.75 THz, we found S = 0.93 for the reference wavefront and S = 0.97 for the corrected one. This correction shows that the phase aberrations, already quite small prior to compensation since a Strehl ratio of 93% already corresponds to a diffraction-limited regime, are nearly fully corrected by the AO system. Using the same parameters for the DM deformation, i.e. adapted to the correction of the 0.75 THz wavefront, it is important to evaluate if this correction is also effective for the other frequencies of the broadband THz wave. Therefore, we measured the reference and corrected THz wavefronts for other frequencies and calculated the corresponding Strehl ratios, being in mind that the DM shape is actually set for the correction of the 0.75 THz wavefront. Fig. 5 represents the evolution of the reference and corrected Strehl ratios as a function of the frequency. We observe that the correction is effective in the 0.6-0.9 THz spectral region. Out of this band, the corrected Strehl ratios become lower than the reference ones, indicating that the aberrations of the THz beam depend on the wavelength like chromatic aberrations.

In conclusion, by means of 2D EO imaging of THz waveforms and subsequent utilization of a DM, we were able to control and minimize the geometrical aberrations of a THz wave. The precision of the wavefront measurement is $\lambda/60$, without any prior reference measurement. This work demonstrates the potential of AO technology for the optimization of THz beam quality. Further developments will consist in modifying the optical arrangement so that the phase shift induced by the DM will also provide the amplitude correction of the THz wave that will be essential for further practical or fundamental applications.

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Fig. 5. Spectral dependence of the Strehl ratios for reference (before correction) and corrected wavefronts.

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